

Refine Search

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| DEPOSITION | 528869 |
| CHAMBER | 1949356 |
| OFFSET | 814348 |
| DATA | 3414229 |
| STRUCTURE | 4506331 |
| COMPUTER | 1509662 |
| RESOLVE | 80145 |
| DIFFERENCES | 548359 |
| BETWEEN | 10605052 |
| MEASUREMENTS | 488282 |
| MEMOR\$3 | 0 |
| ((DEPOSITION ADJ CHAMBER) AND (OFFSET ADJ DATA ADJ STRUCTURE) AND (COMPUTER ADJ MEMOR\$3) AND (RESOLVE ADJ DIFFERENCES ADJ BETWEEN ADJ MEASUREMENTS)).PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD. | 3 |

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L19

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| <u>L15</u> | (deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) | 34 | <u>L15</u> |
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END OF SEARCH HISTORY